PROCEEDINGS OF SPIE

Emerging Digital Micromirror Device Based Systems and Applications III

Michael R. Douglass Patrick I. Oden Editors

26 January 2011 San Francisco, California, United States

Sponsored by SPIE

Cosponsored by Texas Instruments Inc. (United States)

Published by SPIE

Volume 7932

Proceedings of SPIE, 0277-786X, v. 7932

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

The papers included in this volume were part of the technical conference cited on the cover and title page. Papers were selected and subject to review by the editors and conference program committee. Some conference presentations may not be available for publication. The papers published in these proceedings reflect the work and thoughts of the authors and are published herein as submitted. The publisher is not responsible for the validity of the information or for any outcomes resulting from reliance thereon.

Please use the following format to cite material from this book:

Author(s), "Title of Paper," in Emerging Digital Micromirror Device Based Systems and Applications III, edited by Michael R. Douglass, Patrick I. Oden, Proceedings of SPIE Vol. 7932 (SPIE, Bellingham, WA, 2011) Article CID Number.

ISSN 0277-786X ISBN 9780819484697

Published by **SPIE** P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445 SPIE.org

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Printed in the United States of America.

Publication of record for individual papers is online in the SPIE Digital Library.



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Introduction

We are once again pleased to have chaired a MOEMS/MEMS conference at SPIE Photonics West. For the third year, our conference was an exciting forum for presenting and networking with colleagues in this internationally recognized symposium.

The Digital Micromirror Device (DMD) was conceived at Texas Instruments in 1987, following a decade of work on analog deformable-mirror and cantilever-mirror devices. This particular MOEMS device has been applied most famously to conference room and portable projectors, large-screen high-definition televisions, and digital cinema projection systems, all of which were enabled by DLP® technology.

As evidenced in this well-attended conference at Photonics West 2011, the DMD and associated development platforms are enabling many exciting new systems and applications beyond the traditional display technologies. The goal of this conference was to bring together scientists, technologists, and developers working on applications in these emerging markets. In that regard, it was a rousing success. In these proceedings, you will find 18 very interesting papers covering a wide range of applications. We categorized them into four separate sessions:

Session 1 – Medical Applications Using Hyperspectral Imaging

Session 2 – Direct Imaging and Beam Projection

Session 3 – 3D Measurement Systems Using Structured Light

Session 4 – Multi-Spectral Metrology and Microscopy.

Our five invited authors are considered experts in their fields and we are honored that they participated in our conference. They and the other authors shared their progress on developing new applications using a DMD to process light. Many of the developers are now using DLP® Discovery kits which include a DMD along with supporting components.

We want to thank our program committee for the great work they did developing the conference concept, finding all these wonderful speakers, and organizing the papers into a cohesive structure. Special thanks go to the session chairs for working with their authors, coordinating the conference, and keeping it on schedule. And of course extra special thanks to the authors who did a fantastic job presenting their subjects in an interesting and passionate way. You made the conference a success. We also want to thank Dr. Thomas Suleski and Dr. Harald Schenk (symposium chair and cochair) for their support and guidance. And of course thanks to the SPIE staff for keeping us on task.

If you were able to attend the conference, we know you enjoyed it and are looking forward to reading more about these interesting DMD applications. For those who did not attend, we hope you enjoy reading the papers as well. Keep those innovations coming; who knows what might be around the next corner.

> Michael R. Douglass Patrick I. Oden